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## A+12800 IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

TRADEM re the Application of: Smith et al.

Docket No.: TI-29811

Serial No.: 09/975,639

nit: 2818

MAILING CERTIFICATE UNDER 37 C.F.R. §1.8(A)

I hereby certify that the above correspondence is being deposited

Filed: 10/11/01

Examiner: Hoang, Quoc

Title: Hydrogen Plasma Photoresist Strip And Polymeric Residue Cleanup Process

For Low Dielectric Constant Materials

## REPLY UNDER 37 CFR 1.116 – EXPEDITED PROCEDURE **TECHNOLOGY CENTER 2800**

October 22, 2003

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Alexandria, VA 22313-1450

Postal Service as First Class Mail in an

envelope addressed to: Commissioner for Patents, P.O. Box 1450,

Dear Sir:

In response to the Office Action, dated 08/25/03, in the above-identified patent application, please make the following amendments. They are respectfully submitted as a full and complete response to that Action. Charge any remitted fees to the deposit account of Texas Instruments Incorporated, Account No. 2007 CENTER 2800 0668.

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submit that if such a combination was "obvious", than the Examiner should be able to provide art that teaches the advantageously claimed mixture.

Claims 51-59 have been added hereinabove. These claims are closely related to original claims 40-50 filed in the initial patent application.

Claim 60 has also been added hereinabove. It is closely related to currently pending Claim 1. Lastly, Claims 61-68 have been added hereinabove. These claims are closely related to original claims 1, and 21-29 filed in the initial patent application.

For the reasons stated above, this application is believed to be in condition for allowance. Reexamination and reconsideration is requested.

Respectfully submitted,

Rose Alyssa Keagy Attorney for Applicants

Reg. No. 35,095

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